

ASMX.291A



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Todd et al.	Group Art Unit 1762
App. No.	:	10/074,563	
Filed	:	February 11, 2002	
For	:	PROCESS FOR DEPOSITION OF SEMICONDUCTOR FILMS	
Examiner	:	Timothy Howard Meeks	

RECEIVED
MAY 12 2003
TC 1700

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed. This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required in accordance with 37 C.F.R. § 1.97(b)(3). If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 5/6/03

By: Joseph J. Mallon
Joseph J. Mallon
Registration No. 39,287
Attorney of Record
Customer No. 20,995
(619) 235-8550

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.291A	APPLICATION NO. 10/074,563
<i>P E</i> INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>0 9 2003</i> <i>(USE SEVERAL SHEETS IF NECESSARY)</i>	APPLICANT Todd et al.	
	FILING DATE February 11, 2002	GROUP 1762

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

**EXAMINER
INITIAL**

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

S:\DOCS\JOM\JOM-4741.DOC:050603

EXAMINER _____ **DATE CONSIDERED** _____

***EXAMINER:** INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.